



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Confirmation No.: 1096

Applicants : Toshiharu DAI, et al.
Serial No. : 10/774,529
Filed : February 10, 2004
Examiner : Chuong A. Luu
Art Unit : 2818
For : SEMICONDUCTOR WAFER PROCESSING METHOD

REQUEST FOR RECONSIDERATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed June 30, 2005, please consider the following remarks.

This Request for Reconsideration is being filed with a Petition for Extension of Time (One-Month) and a check for the sum of \$120, in payment of the required extension fee.